

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Janis Virbulis et al.

Group Art Unit: 1722

Examiner: Matthew J. Song

Serial No.: 10/053,446

Filed: January 17, 2002

For: PROCESS AND APPARATUS FOR PRODUCING  
A SILICON SINGLE CRYSTAL

Attorney Docket No.: WSAG 0128 PUS

**AMENDMENT UNDER 37 C.F.R. § 1.111  
AND PETITION FOR EXTENSION OF TIME  
UNDER 37 C.F.R. § 1.136(a)**

Mail Stop Amendment  
Commissioner for Patents  
U.S. Patent & Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby petitions for a one-month extension of time to respond to the Office Action mailed February 2, 2006, thereby extending the time period within which to respond to June 2, 2006.

In response to the Office Action mailed February 2, 2006, please amend the above-identified application as follows: